

Form PTO-1449

**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**

JUL 01 2002

(Use several sheets if necessary)

Docket Number (Optional)
4368US (99-0959)

Application Number
09/874,631

Applicants **Moon et al.**

Filing Date **June 5, 2001**

Group Art Unit **2815**

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>gvl</i>	4,807,021	02/1989	Okumura	—	—	
<i>gvl</i>	5,366,794	11/1994	Nakao	—	—	
<i>gvl</i>	5,385,869	01/1995	Liu et al.	—	—	
<i>gvl</i>	5,397,921	03/1995	Karnezos	—	—	
<i>gvl</i>	5,409,865	04/1995	Karnezos	—	—	
<i>gvl</i>	5,504,277	04/1996	Danner	—	—	
<i>gvl</i>	5,663,530	09/1997	Schueller et al.	—	—	
<i>gvl</i>	5,668,405	09/1997	Yamashita	—	—	
<i>gvl</i>	5,674,785	10/1997	Akram et al.	—	—	
<i>gvl</i>	5,697,148	12/1997	Lance, Jr. et al.	—	—	
<i>gvl</i>	5,710,071	01/1998	Beddingfield et al.	—	—	
<i>gvl</i>	5,719,449	02/1998	Strauss	—	—	

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

gvl

U. S. Patent Application entitled MICROELECTRONIC DEVICES AND METHODS OF MANUFACTURE, filed August 30, 2001, Serial No. 09/944,465.

EXAMINER *gvl*

DATE CONSIDERED *9/02*

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

Form PTO-1449 <div style="border: 1px solid black; border-radius: 50%; padding: 5px; display: inline-block; transform: rotate(-45deg); transform-origin: center;"> INFORMATION DISCLOSURE CITATION IN AN APPLICATION JUL 01 2002 (Use several sheets if necessary) </div>				Docket Number (Optional) 4368US (99-0959)		Application Number 09/874,631	
Applicants Moon et al.				Filing Date June 5, 2001		Group Art Unit 2815	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<div style="writing-mode: vertical-rl; transform: rotate(180deg); font-weight: bold;"> TRADEMARK OFFICE </div>	5,721,151	02/1998	Padmanabhan et al.	—	—	
	5,739,585	04/1998	Akram et al.	—	—	
	5,747,982	05/1998	Dromgoole et al.	—	—	
	5,752,182	05/1998	Nakatsuka et al.	—	—	
	5,758,413	06/1998	Chong et al.	—	—	
	5,798,285	08/1998	Bentlage et al.	—	—	
	5,818,113	10/1998	Iseki et al.	—	—	
	5,834,338	11/1998	Takeda et al.	—	—	
	5,835,355	11/1998	Dordi	—	—	
5,843,808	12/1998	Karnezos	—	—		
5,844,168	12/1998	Schueller et al.	—	—		
5,886,408	03/1999	Ohki et al.	—	—		

FOREIGN PATENT DOCUMENTS							
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						YES	NO

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)

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Form PTO-1449

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SVC	5,973,404	10/1999	Akram et al.	—	—	
SVC	5,984,691	11/1999	Brodsky et al.	—	—	
SVC	5,991,161	11/1999	Samaras et al.	—	—	
SVC	6,008,543	12/1999	Iwabuchi	—	—	
SVC	6,011,694	01/2000	Hirakawa	—	—	
SVC	6,024,584	02/2000	Lemke et al.	—	—	
SVC	6,027,346	02/2000	Sinsheimer et al.	—	—	
SVC	6,050,832	04/2000	Lee et al.	—	—	
SVC	6,057,178	05/2000	Galuschki et al.	—	—	
SVC	6,072,233	06/2000	Corisis et al.	—	—	
SVC	6,075,710	06/2000	Lau	—	—	
SVC	6,079,991	06/2000	Lemke et al.	—	—	

FOREIGN PATENT DOCUMENTS

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						YES	NO

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
SVL	6,093,035	07/2000	Lemke et al.	—	—		
SVL	6,116,921	09/2000	Scholz et al.	—	—		
SVL	6,127,736	10/2000	Akram	—	—		
SVL	6,137,062	10/2000	Zimmerman	—	—		
SVL	6,137,164	10/2000	Yew et al.	—	—		
SVL	6,165,885	12/2000	Gaynes et al.	—	—		
SVL	6,172,422 B1	01/2001	Chigawa et al.	—	—		
SVL	6,179,598 B1	01/2001	Brand	—	—		
SVL	6,191,487 B1	02/2001	Rodenbeck et al.	—	—		
SVL	6,212,768 B1	04/2001	Murakami	—	—		
SVL	6,214,156 B1	04/2001	Takano et al.	—	—		
SVL	6,218,202 B1	04/2001	Yew et al.	—	—		
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Sheet 5 of 5

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<i>[Signature]</i>	6,219,911 B1	04/2001	Estes et al.	-	-	-
<i>[Signature]</i>	6,229,711 B1	05/2001	Yoneda	-	-	-

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